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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Takeshi KAJIYAMA

SERIAL NUMBER: 10/787,133

GROUP: 2826

FILED: February 27, 2004

EXAMINER: PERT, EVAN T

FOR: SEMICONDUCTOR DEVICE WITH UPPER PORTION OF PLUGS CONTACTING
SOURCE AND DRAIN REGIONS BEING A FIRST SELF-ALIGNED SILICIDE

REQUEST TO CORRECT TITLE OF INVENTION

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
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SIR:

In the matter of the above-identified application for patent, we hereby request
correction of your records to reflect the correct title of the invention. The title of the
invention should read as follows: SEMICONDUCTOR DEVICE **WITH UPPER**
PORTION OF PLUGS CONTACTING SOURCE AND DRAIN REGIONS BEING A
FIRST SELF-ALIGNED SILICIDE.

Respectfully Submitted,

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